

INFORMATION DISCLOSURE STATEMENT

Applicant : Kimmo Puhakka et al.
App. No. : 10/532,118
Filed : November 15, 2006
For : FORMATION OF CONTACTS ON
SEMICONDUCTOR SUBSTRATES
Examiner : LUU, CHUONG A.
Art Unit : 2892
Conf. No. : 3934

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

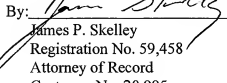
Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing **sixty-five (65)** references to be considered by the Examiner. Also enclosed are **ten (10)** foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. **11-1410**.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 2-22-10

By: 
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